

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kyoung-Ju SHIN et al.  
Assignee: Samsung Electronics Co., Ltd.  
Title: THIN FILM DIODE PANEL AND MANUFACTURING METHOD  
OF THE SAME  
Application No.: 10/578,028 Filing Date: April 27, 2006  
Examiner: Thanh Nhan P. NGUYEN Group Art Unit: 2871  
Docket No.: AB-1883 US Confirmation No.: 9578

Irvine, California  
December 16, 2008

Mail Stop Amendment  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION**

Dear Sir:

In response to the Office Action dated October 2, 2008, please amend the above-identified application as follows.